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+ Practice Limited to  
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Re: U.S. Patent No. 7,289,212  
Issued: October 30, 2007  
For: **Lithographic Apparatus, Device Manufacturing Method and Device Manufacturing Thereby**  
Patentee: Yim Bun Patrick KWAN  
Our Ref: 1857.5280001

Sir:

Transmitted herewith for appropriate action are the following documents:

1. Power of Attorney to Prosecute Applications Before the USPTO; and
2. Statement Under 37 C.F.R. 3.73(b).

*The above-listed documents are filed electronically through EFS-Web.*

The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

Respectfully submitted,

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Enclosure(s)

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